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## \*BIBDATASHEET\*

CONFIRMATION NO. 2337

Bib Data Sheet

<b>SERIAL NUMBER</b> 10/501,672	<b>FILING OR 371(c) DATE</b> 07/16/2004 <b>RULE</b>	<b>CLASS</b> 117	<b>GROUP ART UNIT</b> 1722	<b>ATTORNEY DOCKET NO.</b> 2004_1129A
<b>APPLICANTS</b> Hiroshi Takeno, Annaka-shi Gunma, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/00345 01/17/2003				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-16663 01/25/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 2	<b>TOTAL CLAIMS</b> 6
<b>INDEPENDENT CLAIMS</b> 2				
<b>ADDRESS</b> 513				
<b>TITLE</b> SILICON EPITAXIAL WAFER AND PROCESS FOR MANUFACTURING THE SAME				
<b>FILING FEE RECEIVED</b> 1220	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	